

Recent progress in Si-W ECAL for ILD

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on behalf of SiW group from LLR, LAL, LPNHE and LPSC (France).

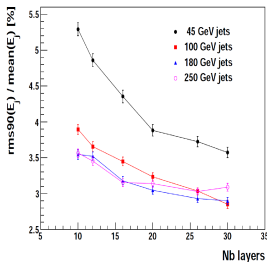
LCWS, Belgrade, 7 Oct 2014

Why only silicon ECAL in France?

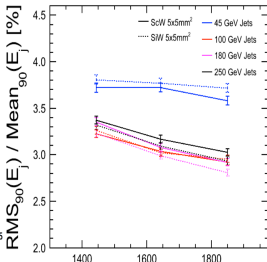
- ILC potential depends on both accelerator and detector. The latter should be considered as part of overall project. **Cost savings with fully scintillator ECAL** (~ 50 MILCU depending on ILD radius, cost of SiPM calibration etc.) are **<1%** of total ILC cost (~ 7 -8 GILCU). Only one ILC detector is needed from physical (not political) point of view.
- Silicon advantages:
 - **better granularity,**
 - perfect linearity, easy calibration, time stability, robustness,
→ therefore, **low systematics.**
- No convincing argument on scintillator performance from simulation, as **scintillator systematics** (SiPM saturation, scintillator response non-uniformity, temperature dependence etc.) **was not included in MC up to now.**
- Concerning hybrid ECAL option, with both silicon and scintillator layers: **complexity** increases by >2 , as commissioning of scintillator detectors will be more difficult than silicon. Also **higher risks.**
- **Requirements on systematic errors in ECAL are more stringent than in HCAL.**
Eg. with 25% and 10% of electromagnetic and hadronic jet energy in average:
 $\sigma_E = 2\% \cdot 0.25E$ of **ECAL systematics** translates to $2\% \cdot 0.25 / 0.1 = 5\%$ of **equivalent HCAL systematics.** Note: there may be more π^0 energy in jet due to large fluctuations.
- Synergy with **CMS endcap Phase 2 upgrade project HGCAL** also with silicon technology (alternative: shashlyk option, final choice in spring 2015).

Optimization studies

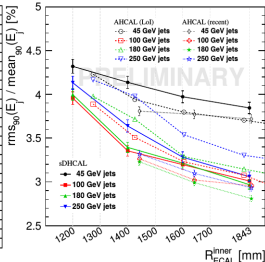
Possible scenario: reduce inner ECAL radius from 1.843 to ~ 1.5 m, number of layers $29 \rightarrow \sim 25$, **ECAL cost by $\sim 40\%$** with corresponding reductions of TPC, HCAL, muon and magnet yoke costs.



DBD (H.Trn, SiW+AHCAL)



J.S.Marshall (Si/Sc+AHCAL)

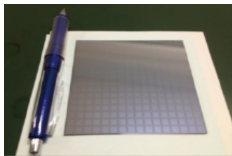


H.Trn (Si+AHCAL/SDHCAL)

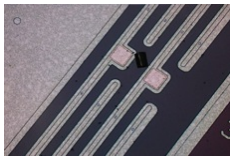
Plan: work on engineering design.

Si producers

- **HPK Hamamatsu** offer: 2.54 EUR/cm² if they produce all Si ECAL. Same price as in DBD, $\sim 45\%$ of full ECAL cost. Sensors from 6' wafers, 500 μm thick



"no guard ring",
GR with 1, 2 or
4 segments:



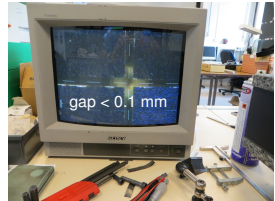
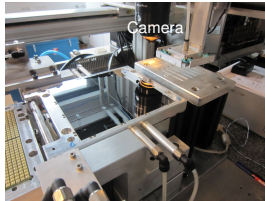
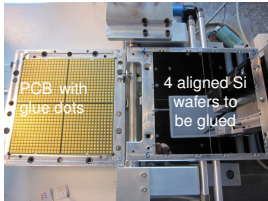
- **LFfoundry in Europe:** agreement with CNRS+Institutes has been signed, first sensors ordered. 8' wafers, 700 μm thick ($\approx 6\%$ better EM resolution).

Sensor gluing

9 sensors have been successfully glued to 9 PCB by robot.

Preparation to glue 4 sensors to new PCB with x4 more channels:

- semi-automated process to position, align and glue 4 sensors to PCB has been developed
- 4 glass plates and 4 unprocessed wafers have been successfully glued



New DAQ electronics

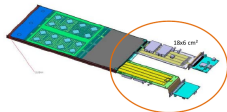
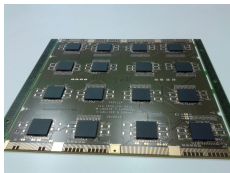
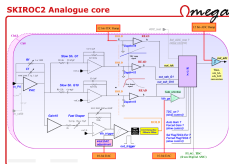
New SKIROC 2B front-end chip production with bug fixes in fall 2014.

3 iterations of **new front-end PCB** serving 4 sensors: designed, produced and partially tested (without sensors). x4 higher density of channels due to BGA chip packaging. 2.8 mm thickness.

New low voltage/clock board serving one detector element ("slab") with several front-end PCBs has been designed, produced and tested.

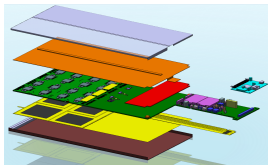
Test production of thinner (1.2–1.5 mm) **"chip-on-board"** with naked die SKIROC 2 is ongoing in Korean EOS company.

New version of DAQ software (PYRAME + CALICOES) has been written and tested.

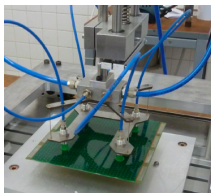


Detector assembly

- **short slab** with 1 front-end PCB and 4 sensors, production by end of this year

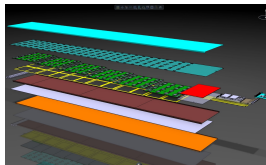


Carbon support + HV Kapton + PCBs with 4 sensors + Cu cooling + cover



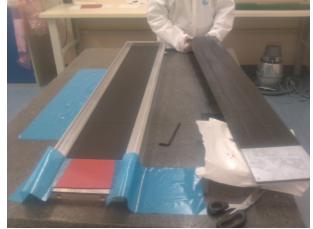
One assembly bench

- **long slab**, up to 8 front-end PCBs connected together, production next year

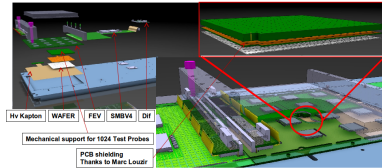


R&D of mechanical design

ILD slab: W absorber in carbon-fiber structure sandwiched between two active layers. Production of full-scale W + carbon-fiber absorber is planned. Same structure fully in carbon has been already built.

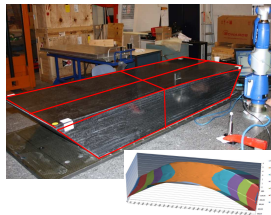


To test sensors without permanent gluing (eg. before detector assembly):
setup with 1024 spring contacts
(instead of glue) btw PCB and sensors.

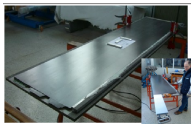


Structure with alveoli

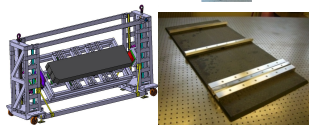
Big prototype (3/5 of ILD barrel module) has been built in 2011, **5 years of R&D**, ~600 kg. Separate layers of carbon fiber + W “cooked” together. Simulated mechanically & thermally.



Similar endcap structure is being designed. Long 2.5 m module for endcap with 3 alveoli has been built.



Special transport & handling tools, fastening rails are under development.



Thermal simulations eg. in endcap alveola:
passive cooling is sufficient.

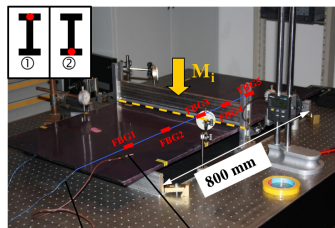
End Cap : (2.5m)



$\Delta T = 6^{\circ}\text{C}$

Measurements with Bragg grating fibers

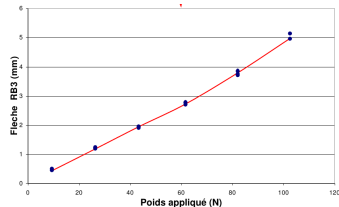
Another prototype with **molded Bragg grating fibers**. Detailed verification of simulated elongations under loads (by monitoring frequency shift of light reflected by fiber).



Optical fiber Thermal sensor

Correlation with the experimental data (FBGs):

	Load (N)	ϵ_{yy} FBG1 ($\mu\text{m/m}$)		ϵ_{yy} FBG2 ($\mu\text{m/m}$)		ϵ_{yy} FBG3 ($\mu\text{m/m}$)		ϵ_{yy} FBG4 ($\mu\text{m/m}$)		ϵ_{yy} FBG5 ($\mu\text{m/m}$)	
		Exp.	Simu.	Exp.	Simu.	Exp.	Simu.	Exp.	Simu.	Exp.	Simu.
M1	9,38	-2,52	14	-12,6	-12,2	-29,86	-36,8	-7,41	-8,1	4,91	29
M2	26,35	0,84	27,8	-32,77	-30,6	-92,9	100,7	-24,72	-26,5	15,55	42,51
M3	43,32	10,92	41,1	-53,78	-49,1	-156,77	165,6	-39,55	-44,9	26,2	55,8
M4	61,64	21,01	55,4	-78,16	-69	-235,57	237	-59,33	-64,8	31,11	70
M5	82,08	33,61	71,5	-109,26	-91,4	-336,77	319,6	-79,93	-87,1	44,21	86,2
M6	102,53	48,74	87,4	-145,4	-117,7	-468,66	413,7	-115,37	-112,8	58,13	102,2



Vérification des paramètres du modèle en comparant la flèche FBG3 mesurée et simulée

Conclusions

- No convincing argument for large ECAL radius.
Plan: develop engineering design with **smaller radius and number of layers**.
- potential **Si producers**:
 - Hamamatsu HPK, 2.5 EUR/cm², 6' wafers, 500 μm
 - LFoundry (Europe), 8', 700 μm
 - ...
- FE chip **SKIROC 2B** production by end of 2014,
new FE PCB with x4 channels (ILD channel density),
new LV/clock board,
gluing of 4 sensors per PCB,
 - assembly of short slab with one FE PCB by end of 2014,
 - long slab with many FE PCBs in 2015
- **mechanical design + prototyping** is ongoing.